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APPLICANTS

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** CONTINUING DATA *****

This application is a DIV of 10/396,407 03/26/2003 PAT 6,709,531
which is a DIV of 09/784,200 02/16/2001 PAT 6,579,382*MK (verified)*

** FOREIGN APPLICATIONS *****

JAPAN P2000-39683 02/17/2000
JAPAN P2000-297441 09/28/2000

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Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY	SHEETS DRAWING	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	JAPAN	18	20	2
Verified and Acknowledged	<i>curly</i> <i>MK</i>	Examiner's Signature Initials			

ADDRESS

22852
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TITLE

Chemical liquid processing apparatus for processing a substrate and the method thereof

 All Fees